PROCEEDINGS OF SPIE

Vertical-Cavity Surface-Emitting Lasers XIX

Chun Lei Kent D. Choquette Editors

11–12 February 2015 San Francisco, California, United States

Sponsored and Published by SPIE

Volume 9381

Proceedings of SPIE 0277-786X, V. 9381

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Vertical-Cavity Surface-Emitting Lasers XIX, edited by Chun Lei, Kent D. Choquette, Proc. of SPIE Vol. 9381, 938101 · © 2015 SPIE · CCC code: 0277-786X/15/\$18 · doi: 10.1117/12.2191730

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Author(s), "Title of Paper," in *Vertical-Cavity Surface-Emitting Lasers XIX*, edited by Chun Lei, Kent D. Choquette, Proceedings of SPIE Vol. 9381 (SPIE, Bellingham, WA, 2015) Article CID Number.

ISSN: 0277-786X ISBN: 9781628414714

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445 SPIE.org

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Printed in the United States of America.

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